

AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Yeo et al.	Docket No.:	TSM03-0847
Serial No.:	10/826,602	Art Unit:	1795
Filed:	April 16, 2004	Examiner:	Raymond, Brittany L.
For:	Lithography Apparatus for Manufacture of Integrated Circuits		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.116

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated February 11, 2009, which Action is made final. Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of the claims.